

Notice of References Cited	Application/Control No. 10/035,387	Applicant(s)/Patent Under Reexamination CHAN ET AL.	
	Examiner Huy K. Mai	Art Unit 2873	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2003/0076575	04-2003	Stappaerts, Eddy A.	359/291
	B	US-2003/0025981	02-2003	Ishikawa et al.	359/290
	C	US-5,652,672	07-1997	Huignard et al.	359/292
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
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FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

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